# Miscellaneous Organic Chemical Manufacturing NESHAP (MON) Risk and Technology Review 40 CFR 63, Subpart FFFF

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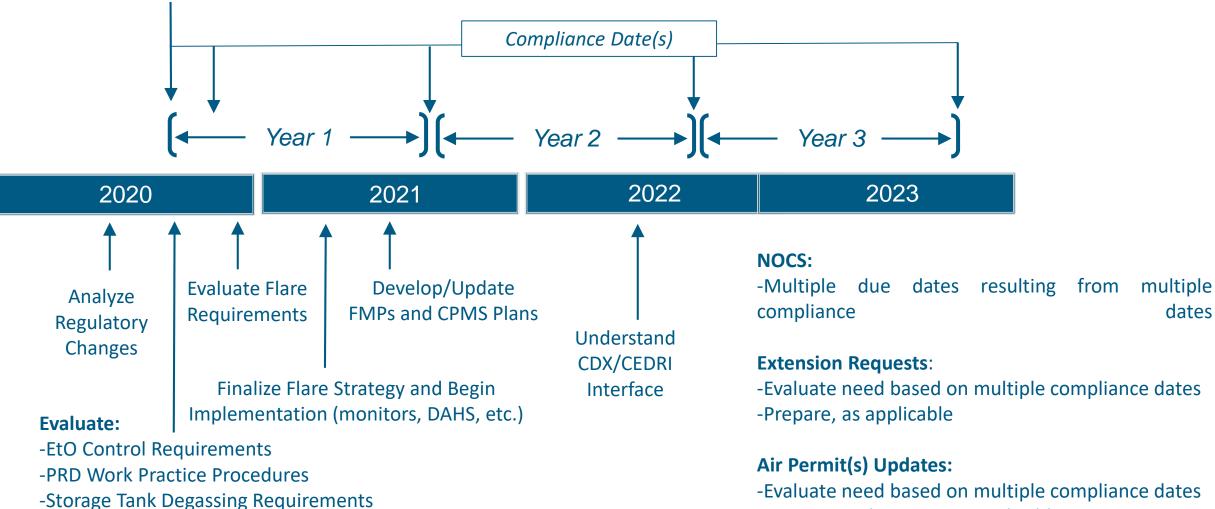


#### **Agenda**

- What will we cover today?
  - Outcome of EPA's review of the MON rule
  - Rule updates that were finalized
  - Changes from proposal
  - Some detail on the new flare requirements
  - What actions to take now



# Federal Register Publication MON: The Path Forward



- - -Prepare applications, as applicable.

-Adsorber Requirements

-Heat Exchanger LDAR Requirements

Develop Compliance Approach. Consider Capital Expenditures (e.g., control equipment, DAHS), Turnarounds, and Air Permitting Requirements. Develop Calendar and Key Milestones.



#### Housekeeping

- How to ask questions?
  - Please enter your questions in the chat box.
  - Q&A at the end.
- Can I get a certificate of completion?
  - Yes, webinar attendees will receive a certificate upon request.
  - Continuing Education for Certifications/Licenses.



## Why did EPA Update the MON?

- EPA is obligated to perform a risk and technology review (RTR) of each promulgated Part 63 MACT standard.
  - Risk Review once.
  - Technology Review every 8 years.
  - Risk additional standards needed to provide an ample margin of safety to protect public health?
  - Technology have there been cost-effective developments in practices, processes, or controls?



#### Who is Subject to the Rule?

- Miscellaneous organic chemical manufacturing process units (MCPU) units located at major sources.
  - Produce materials described in 40 CFR 63.2435(b)(1)
  - Process, use, or generate HAP
  - Not an affected source under another NESHAP (except for certain batch process vents)
- Requirements for storage vessels, process vents, transfer racks, equipment leaks, wastewater and liquid streams, and heat exchange systems.



# **MON Updates**

**Philip Crawford** 





#### Results of the MON RTR

- EPA: Risks are unacceptable.
- Max individual lifetime cancer risk from the source category:
  - 400-in-1 million driven by ethylene oxide (EtO).
- Facility-wide risk:
  - 3,000-in-1 million attributable to EtO.
- Technology Review: Heat exchange system (HES) monitoring and leak definition for light liquid batch pumps.

YOUR ENVIRONMENTAL

 Other changes to address SSM and CAA section 112(d)(2) and (d)(3).

#### **Changes to Address Risk**

- New Standards for Equipment "In Ethylene Oxide Service":
  - Process Vents: uncontrolled ≥ 1 ppmv and combined ≥ 5 lb/yr of EtO
  - Storage Tanks: any capacity/vapor pressure storing liquid with ≥ 0.1% by weight EtO
  - Equipment Leaks: equipment that contains or contacts fluid ≥ 0.1% by weight EtO
  - If info suggests EtO could be present, analysis is required to rule out



# **Changes to Address Risk (Cont.)**

#### Process Vents & Storage Tanks in EtO Service:

- Control Requirements
  - Flare meeting new monitoring requirements
  - Control device (CD) with 99.9% emissions reduction
  - -< 1 ppmv</pre>
  - < 5 lb/yr EtO for all combined vents (not available for tanks)

- Testing
  - Initial VE demonstration for flares
  - Initial/5 year testing for CDs
  - CEMS alt. for 1 ppmv option

- Monitoring
  - New flare monitoring requirements
  - Monitoring parameters for scrubbers and thermal oxidizers
  - CEMS alt. for 1 ppmv option



# **Changes to Address Risk (Cont.)**

- Equipment in EtO Service:
  - Comply with 40 CFR 63 Subpart H or UU, or 40 CFR 65 Subpart F and:

Equipment	Leak Definition	Monitoring Frequency	Repair Required	
Pumps	1,000 ppm	Monthly	Within 15 days	
Connectors	500 ppm	Annual		

- New or replaced pumps and connectors must be monitored w/in 5 days of initial startup
- New PRD requirements (covered later) except any release is a deviation
- Several provisions in H, UU, and F don't apply see §63.2493(e)



#### **Technology Review – Heat Exchangers**

- Modified El Paso Method
  - Initial monthly monitoring (6 months), then quarterly
  - Leak definition: <u>6.2 ppmv of total strippable hydrocarbon</u> in the stripping gas (as methane).
  - Monitoring location < 40,000 gpm for combo of multiple once through systems</li>
  - Small systems (≤ 10,000 gpm): Alternative mass-based leak definition of 0.18 kg/hr.
- Repair leaks and re-monitor in 45 days.
  - DOR available, unless the leak is greater than 62 ppmv (or 1.8 kg/hr for small systems).
- Removed monitoring exemptions for once-through systems subject to NPDES permits.



#### **Technology Review – Equipment Leaks**

- Revised Leak Definition for Pumps:
  - Light liquid, batch process, existing source 10,000 ppm to 1,000 ppm
- Monitor any new/replaced equipment within 30 days
  - Only applies to equipment subject to periodic M21 monitoring
  - Does not apply to unsafe/difficult to monitor equipment



#### Other Rule Revisions

#### Pressure Relief Devices

- Post Release Monitoring
  - Below 500 ppm within 5 days, or replace the rupture disk, if equipped
- Rupture disk only:
  - Must replace within 5 days
  - Cannot restart until replaced
- Work practices
  - PRD management program
  - Release monitoring
  - RCA/CAA analysis for releases



- Storage Vessels Degassing (Fixed and Floating Roof)
  - Control until the vapor space is less than 10% of the LEL.
  - Performance demonstrations are required:
    - Subpart SS testing/design evaluation, MR&R.
    - Subpart CC requirements also apply for flares.
- Bypass Lines
  - No bypass of a control device is allowed.
  - HAP emissions from bypass must be reported.



#### Maintenance Vents

- Prior to venting, liquids must be removed as much as practical and equipment depressurized to a flare or control device until one of the following criteria are met:
  - Vapor has an LEL < 10% and <20 ppmv of hydrogen halide/halogen HAP</li>
  - If LEL cannot be measured, the pressure in the equipment is reduced to 5 psig or less, and upon opening, active purging cannot be used until the LEL is < 10%;
  - Equipment contains less than 50 pounds of VOC;
  - If none of the above can be met prior to installation/removal of a blind, then
    pressure must be reduced to 2 psig or less before installation/removal of blind.
    Active purging can be used during blind installation/removal provided pressure at
    purge gas introduction location is 2 psig or less.

PLIANCE IS CLEARLY

#### Adsorbers

- Non-regenerative and Regenerated Off-Site
- 2 adsorbers in series
- Monitor for breakthrough

Remaining Bed Life	Monitoring Frequency		
>2 Months	Monthly		
< 2 Months, >2 Weeks	Weekly		
< 2 Weeks	Daily		

Replace spent bed after breakthrough



#### Overlap Provisions:

- Part 63, Subparts I, GGG, or MMM Affirmative defense requirements no longer apply
- Added Part 60, Subpart VVa to §63.2535(k)
- Flares MON or RSR only



#### Other changes:

- Standards apply at all times (SSM exemption removed)
- Electronic Reporting Requirements
- Additional and revised definitions



#### Flares

- Revised MR&R requirements (Subpart CC)
- Visible emissions work practices for emergency flaring
- Standards for pressure-assisted multi-point flares
- Only applies to subset:
  - Controlling sources in EtO service; or,
  - MCPUs that manufacture ethylene, propylene, polyethylene, and/or polypropylene <u>as a product</u>.



#### Flare Monitoring

- Flame Presence
- No visible emissions (except 5 minutes during any 2 consecutive hours)
- V<sub>tip</sub> < 60 fps, or less than:

$$\log_{10}(V_{max}) = \frac{NHV_{vg}+1,212}{850}$$
, where  $V_{max}$  is limited to 400 fps

- NHV<sub>cz</sub> ≥ 270 Btu/scf
- Net heating value dilution parameter (NHV $_{dil}$ )  $\geq$  22 Btu/ft $^2$  for flares with perimeter assist air



- Pressure-Assisted Multi-Point Flares
  - Tip velocity standards do not apply
  - $NHV_{cz} \ge 800$  Btu/scf
  - Monitor stages for pilot flame presence
  - Cross-lighting burners
    - 6 ft. on center or less
    - Cross-lighting demonstration can be performed for burner spacing > 6 ft
  - Monitor flare header pressure and valve positions to ensure proper operation
  - Can operate under approved alternative means of emission limitations

- Emergency Flaring Work Practice Visible Emissions
  - Flare management plan
  - Conduct RCA/CAA and implement corrective actions
  - Violation:
    - Events due to operator error or poor maintenance;
    - And, except for force majeure events:
      - Two events in 3-calendar years from a single flare for the same root cause and same equipment;
      - Three events in 3-calendar years from a single flare for any reason.

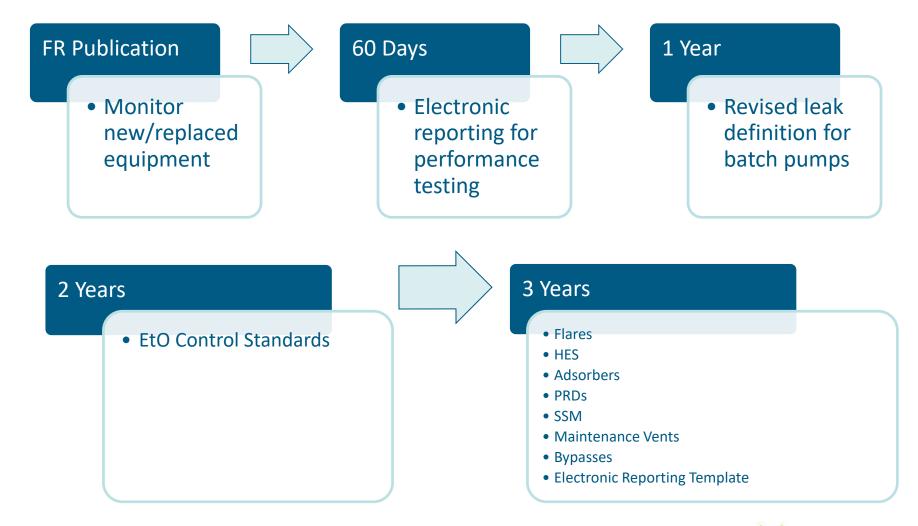


#### **Proposed Changes that were not Finalized**

- Control Option 2 for Equipment in EtO Service
  - Leakless pump/valves requirements.
- Flares
  - Not finalizing the work practice standard for velocity exceedances for flares operating above smokeless capacity (velocity limit must be met at all times).



#### **Compliance Timelines**





# COMPLYING WITH THE NEW FLARE REQUIREMENTS

**Eric Swisher** 





#### Flare Performance Indicators

- Indicators of "Good" Flare Combustion
  - No Visible Emissions (i.e., No Smoking)



- Combustion Efficiency (CE)
- Destruction Removal Efficiency (DRE)

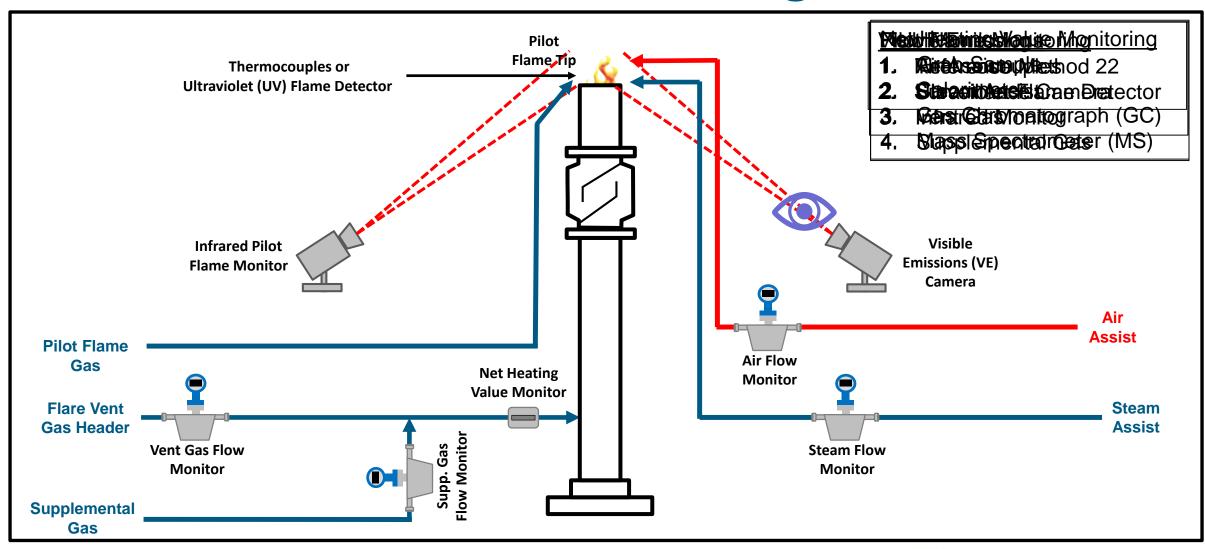


#### Flare Monitoring Indicators

- Pilot Flame or Flame Presence
- Combustion Zone Neat Heating Value (NHV<sub>cz</sub>)
- Tip Velocity (V<sub>tip</sub>)
- Visible Emission
  - ☐ U.S. EPA Reference Method 22 (◎)
  - Optical Camera ( )



#### Flare Monitoring



# Flare CPMS Monitoring Plan

- Description of the Monitoring Equipment
  - Type
  - Justification
- Routine QA/QC Procedures
  - Initial
  - Ongoing
- Description of the Data Collection and Reduction System
  - "Black Box"
  - Process Controls



## **Monitoring Plan Description**

#### Flare Vent Gas Flow Rate Monitoring

Parameter	Minimum Accuracy Requirement	
Flare Vent Gas Flow Rate	± 20% of flow rate at velocities from 0.03 to 0.3 meters per second	
	± 5% of flow rate at velocities greater than 0.3 meters per second (1 foot per second)	

#### Flare Vent Gas Composition Monitoring

- Calorimeter (optional Hydrogen Analyzer)
- Gas Chromatograph (GC)
- Mass Spectrometer (MS)



## Routine QA/QC Procedures

- Flare Vent Gas Flow Rate Monitoring
- Calibration and Verification
  - Tolerances
- System Response Check
- Preventive and Corrective Maintenance Programs



# Performance Specification 9 (PS-9)

#### GC and MS

Calibration/Validation	Frequency	Cylinder Gas	Concentrations	Place of Injection
Multi-Point Calibration/Validation	Initial & Quarterly	Certified Standard	Low, Mid, High	Analyzer
7-Day Drift Test	Initial	Certified Standard	Low, Mid, High	Analyzer
Performance Audit Test	Initial & Quarterly	U.S. EPA Audit U.S. EPA Protocol Certified Standard	Mid	Probe
Mid-Level Validation	Daily	Certified Standard	Mid	Analyzer



#### **Data Collection and Reduction System**

- 15-minute Block Averages
- "Regulated Material" or "Intermittent Flaring"
- Good vs. Bad Data
- Process Integration
- Compliance Demonstration
- Reporting



#### **Data Acquisition System Process**

- Infrastructure
- Integration
- Configuration
- Verification
- Implementation



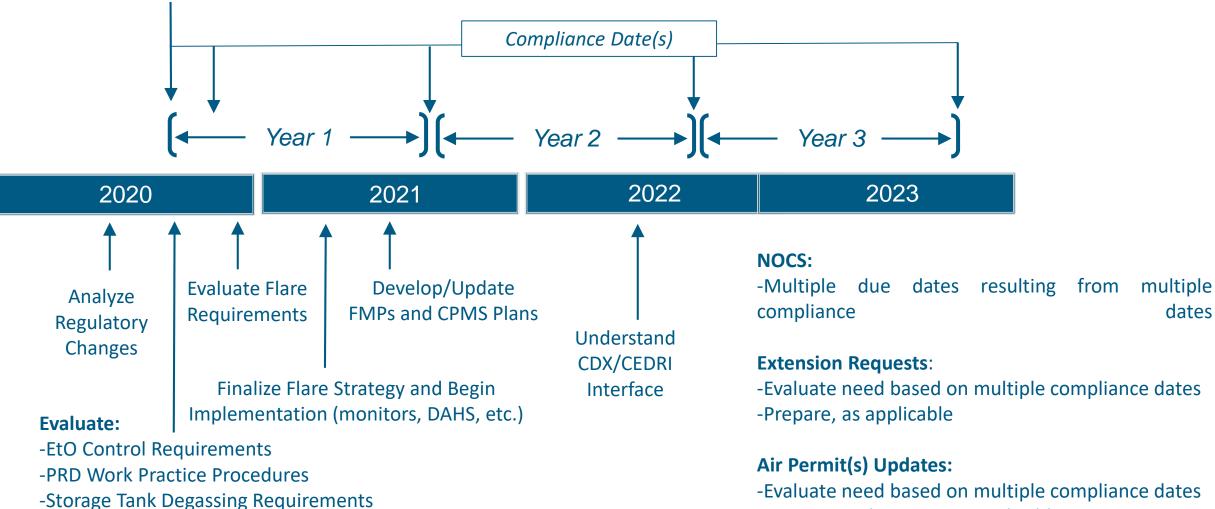
#### THE PATH FORWARD

Kristin Gordon





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# **Questions?**

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